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Sheet 1 of 1

Application No. :

Filing Date :

First Named Inventor: H. OKUMURA

Group Art Unit : 1725

Examiner Name :

Attorney Docket No. : NECA 20.494

**U.S. PATENT DOCUMENTS**

Examiner Initials	Cite No. <sup>1</sup>	U.S. Patent Document	Kind Code if known <sup>2</sup>	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear

**FOREIGN DOCUMENTS**

Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document Office <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Country	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear
SMH		8-071780	JP	TDK Corp.	03-19-1996	
SMH		5-211167	JP	Nec Corp.	08-02-1993	

**Other Prior Art-Non Patent Literature Documents**

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date page(s), volume-issue number(s), publisher, country, where published, source.	Applicant check her if English language translation attached
SMH		T. NOHDA et al. Improving the Uniformity of Poly-Si Films using an Excimer Laser Annealing Method. The Institute of Electronics, Information and Communication Engineers. December 10, 1992. pgs 53-58 Vol. 92 No.368	
Examiner Signature	S. Heinrich		Date Considered Feb 04, 2005

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